1765

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Karola Richter et al.

Serial No:

10/553,728

Art Unit: 1765

Filing Date: October 14, 2005

Title:

SILICON SUBSTRATE COMPRISING POSITIVE

ETCHING PROFILES WITH A DEFINED SLOPE ANGLE AND

PRODUCTION METHOD

Examiner:

Patricia Ann George

October 12, 2007

Attorney's Docket No.: HMP201T1

## TRANSMITTAL LETTER

Hon. Commissioner for Patents and Trademarks

P.O. BOX 1450

Alexandria, Virginia 22313-1450

SIR:

Transmitted herewith for filing is:

<X> AMENDMENT dated October 12, 2007

<X> The Commissioner is hereby authorized to charge any fees under 37 CFR. 1.16, 1.17 and 1.18 or any additional fees which may be required during the entire pendency of the application, or credit any overpayment, to Acct. No.11-0224. A duplicate copy of this sheet is enclosed. If and only if(r) account funds should be insufficient, immediately contact our associate, Lisa Zumwalt, at (703)415-0579, who will pay immediately to avoid deprivation of rights.

< Please charge my Deposit Account No.11-0224 in the amount of \$\_\_\_\_\_. A</p> duplicate copy of this sheet is enclosed.

A signature or signatures required for the above recited document(s) is (are) provided Such signature(s) also provide(s) ratification for any required signature appearing to be defective in the above recited document(s).

Hund M Vranger

Horst M. Kasper, 13 Forest Drive, Warren, N.J. 07059 Reg. No. 28,559 Tel.(908) 526-1717

## **CERTIFICATE OF MAILING under 37 CFR 1.8:**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Hon. Commissioner for Patents, P.O. 1450, Alexandria, VA 22313,

Signature:

OCT 2 4 2007

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